ο-	 	 



Application/Control No.	Applicant(s)/Patent under Reexamination  COILLARD-LAVIROTTE ET AL.	
10/786,918		
Examiner	Art Unit	
John Kim	3733	

	CEAD	CHED	
	SEAR	CHED	γ
Class	Subclasa	Date	Examiner
606	69-71	10/26/2005	JK
623	21.11	10/26/2005	JK
623	21.14	10/26/2005	JK
623	21.15	10/26/2005	JK
623	21.19	10/26/2005	JK
up dat	edsean	2 10/25/66	3 und
aplat	Dsearch	~ 10/25/67S	unch
1			

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
	<u> </u>		ļ

SEARCH NO (INCLUDING SEARCH		)
	DATE	EXMR
see attached search notes east search Inventor's home same	10/26/2005	* <b>(</b>